# 504928602 05/23/2018

# PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT	
NATURE OF CONVEYANCE:	ASSIGNMENT	

#### **CONVEYING PARTY DATA**

Name	Execution Date
AXEL SCHERER	08/31/2017
WILLIAM M. JONES	04/07/2017
DANIL M. LUKIN	05/13/2017
SAMEER WALAVALKAR	08/30/2017
CHIEH-FENG CHANG	03/07/2017

#### **RECEIVING PARTY DATA**

Name:	CALIFORNIA INSTITUTE OF TECHNOLOGY		
Street Address:	reet Address: 1200 E. CALIFORNIA BLVD, MC 6-32		
Internal Address:	OFFICE OF TECHNOLOGY TRANSFER AND CORPORATE PARTNERSHIPS		
City:	PASADENA		
State/Country:	CALIFORNIA		
Postal Code:	91125		

## **PROPERTY NUMBERS Total: 1**

Property Type	Number
Application Number:	15987645

### **CORRESPONDENCE DATA**

**Fax Number:** (732)578-0104

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

**Phone:** 7325780103

**Email:** docketing@kbsiplaw.com

Correspondent Name: KAPLAN BREYER SCHWARZ LLP
Address Line 1: 100 MATAWAN ROAD, SUITE 120
Address Line 4: MATAWAN, NEW JERSEY 07747

ATTORNEY DOCKET NUMBER:	3105-002US2
NAME OF SUBMITTER:	IRENE CHRISTINE
SIGNATURE:	/Irene Christine/
DATE SIGNED:	05/23/2018

PATENT 504928602 REEL: 045887 FRAME: 0179

# Total Attachments: 8 source=Signed\_Assignment\_3105-002us2#page1.tif source=Signed\_Assignment\_3105-002us2#page2.tif source=Signed\_Assignment\_3105-002us2#page3.tif source=Signed\_Assignment\_3105-002us2#page4.tif source=Signed\_Assignment\_3105-002us2#page5.tif source=Signed\_Assignment\_3105-002us2#page6.tif source=Signed\_Assignment\_3105-002us2#page7.tif source=Signed\_Assignment\_3105-002us2#page8.tif

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

# Assignment and Agreement

For value received, I/We, Axel SCHERER, of Barnard, Vermont, United States, William M. JONES of Pasadena, CA, United States, Danil M. LUKIN of Pasadena, CA, United States, Sameer WALAVALKAR of Studio City, California, United States, Chiehfeng CHANG of Pasadena, California, United States, hereby sell, assign and transfer to California Institute of Technology, having an office at Office of Technology Transfer and Corporate Partnerships, 1200 E. California Blvd, MC 6-32, Pasadena, California, 91125, United States, and its successors, assigns and legal representatives, the entire right, title and interest, for the United States of America, in and to all of the inventions disclosed and claimed in United States Patent Application Serial No. 15/442408, filed on February 24, 2017, entitled Nanoscale Field-Emission Device and Method of Fabrication, which claims priority to US Patent Application No. 62/299974, filed on February 25, 2016, and US Patent Application No. 62/437806, filed on December 22, 2016, and all the rights and privileges in said applications and under any and all Letters Patent that may be granted in the United States for said inventions. I/We also concurrently hereby sell, assign and transfer to California Institute of Technology the entire right, title and interest in and to any and all divisional, continuation, continuation-in-part, substitute, reissue, and/or reexamination applications claiming the benefit of said application and any and all Letters Patent that may issue therefrom.

I/We also concurrently hereby sell, assign and transfer to California Institute of Technology the entire right, title and interest in and to said inventions for all countries foreign to the United States, including all rights of priority arising from the patent applications aforesaid, and all the rights and privileges under any and all forms of protection, including Letters Patent, that may be granted in said countries foreign to the United States for said inventions.

I/We authorize California Institute of Technology to make application for such protection in its own name and maintain such protection in any and all countries foreign to the United States, and to invoke and claim for any application for patent or other form of protection for said inventions, without further authorization from me/us, any and all benefits, including the right of priority provided by any and all treaties, conventions, or agreements.

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I/We request that any and all patents for said inventions be issued to California Institute of Technology in the United States and in all countries foreign to the United States, or to such nominees as California Institute of Technology may designate.

I agree that, when requested, I shall, without charge to California Institute of Technology but at its expense, sign all papers, and do all acts which may be necessary, desirable or convenient in connection with said applications, patents, or other forms of protection.

Axel SCHERER and Date

William M. JONES and Date

Attorney Docket: 3105-002US1

# Serial Number: 15/442408

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Axel SCHERER and Date			
William M JONES and Date			

May 13, 2017

Danil M. LUKIN and Date

Sameer WALAVALKAR and Date

Chieh-feng CHANG and Date

- 2 of 2 -**PATENT** 

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Axel SCHERER and Date			
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Danil W. LUKIN and Date

MANULAR 08/30/2017

Sameer WALAVALKAR and Date

Chieh-feng CHANG and Date

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Axel	SCHE	<b>RER</b> an	d Date		
Willi	am M	IONES	and C	ate	

Danil M. LUKIN and Date

Sameer WALAVALKAR and Date

Chief-fong Chang Mar/07/2017 Chieh-feng CHANG and Date

- 2 of 2 -